



1762
ifw

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Won et al.

FILING DATE: July 30, 2001

SERIAL NO.: 09/927,698

FOR: Reduction of Electrostatic Charge
on a Substrate during PECVD Process

§ **ART UNIT:** 1762
§
§ **EXAMINER:** Chen, BP
§
§ **CONFIRMATION NO.**
§ **5821**
§
§ **DOCKET:**
§ **006015 DISPLAY/AKT**

MS NON-FEE AMENDMENT

Commissioner for Patents
P.O. BOX 1450
Alexandria, VA 22313-1450

RESPONSE AND AMENDMENT UNDER 37 C.F.R. 1.111

Dear Sir:

In response to an Office Action mailed June 18, 2004 for the above-referenced patent application, Applicants request that the following amendment be entered and remarks considered for the above-referenced patent application. Reconsideration of the pending claims is respectfully requested.

Respectfully submitted,

Date: July 23, 2004
ADLER & ASSOCIATES
8011 Candle Lane
Houston, Texas 77071
(713) 270-5391
BADLER1@houston.rr.com

Benjamin Aaron Adler
Benjamin Aaron Adler, Ph.D., J.D.
Counsel for Applicant
Registration No. 35,423



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

APPLICANT: Won et al.	§	ART UNIT: 1762
FILING DATE: July 30, 2001	§	EXAMINER: Chen, BP
SERIAL NO.: 09/927,698	§	CONFIRMATION NO.
FOR: Reduction of Electrostatic	§	5821
Charge on a Substrate during	§	DOCKET:
PECVD Process	§	006015 DISPLAY/AKT

MS NON-FEE AMENDMENT

Commissioner for Patents
P.O. BOX 1450
Alexandria, VA 22313-1450

CERTIFICATE OF MAILING UNDER 37 C.F.R. 1.8

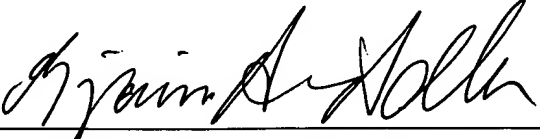
Dear Sir:

I hereby certify under 37 CFR 1.8 that the following correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to MS Non-Fee Amendment, Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450. Please return the enclosed postcard acknowledging receipt of this correspondence.

- 1) Response and Amendment (13 pages).

Respectfully submitted,

Date: July 23, 2004
ADLER & ASSOCIATES
8011 Candle Lane
Houston, Texas 77071
(713) 270-5391
BADLER1@houston.rr.com


Benjamin Aaron Adler, Ph.D., J.D.
Counsel for Applicant
Registration No. 35,423